

08-02-01

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11093 U.S. PTO

Patent Application Transmittal

(only for new nonprovisional applications under 37 C.F.R. 1.53(b))

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11093 U.S. PTO  
09/20170  
08/01/01

Date: August 1, 2001

Attorney Docket No.: 450100-03402

ASSISTANT COMMISSIONER FOR PATENTS  
Box Patent Application  
Washington, D.C. 20231

Sir:

With reference to the filing in the United States Patent and Trademark Office  
of an application for patent in the name(s) of:

Yasushi FUJINAMI

entitled:

IMAGE PROCESSING APPARATUS AND IMAGE PROCESSING METHOD AS WELL AS RECORDING  
MEDIUM

The following are enclosed:

- ☒ Specification ( 61 pages)
- ☒ 11 Sheet(s) of Drawings
- ☒ 12 Claim(s) (including 4 independent claim(s))
- ☐ This application contains a multiple dependent claim

- ☒ Our check for \$ 790.00, calculated on the basis of the claims as amended by any enclosed preliminary amendment as follows:

Basic Fee, \$710.00 (\$355.00)	\$ 710.00
Number of Claims in excess of 20 at \$18.00 (\$9.00) each:	-0-
Number of Independent Claims in excess of 3 at \$80.00 (\$40.00) each: 1	80.00
Multiple Dependent Claim Fee at \$270.00 (\$135.00)	-0-
Total Filing Fee	\$ 790.00
Assignment Recording Fee \$40.00	-0-

- ☒ Oath or Declaration and Power of Attorney

☒ New ☐ signed ☒ unsigned  
☐ Copy from a prior application (37 C.F.R. 1.63(d))

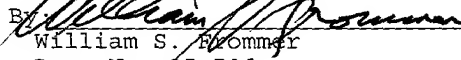
- ☒ Certified copy of each of the following application(s) to substantiate the claim(s) for priority made in the Declaration:

<u>Application No.</u>	<u>Filed</u>	<u>In</u>
2000-233924	2 August 2000	Japan

Please charge any additional fees required for the filing of this application or credit any overpayment to Deposit Account No. 50-0320.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP  
Attorneys for Applicant

By   
William S. Frommer  
Reg. No. 25,506

"Express Mail" mailing label number EL819165520US

Date of Deposit August 1, 2001

I hereby certify that this paper or fee, and a patent application and accompanying papers, are being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and are addressed to the Assistant Commissioner for Patents, Washington, DC 20231.

Charles J. Jones

(Typed or printed name of person mailing paper or fee)

Charles J. Jones

(Signature of person mailing paper or fee)

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August 1, 2001

Assistant Commissioner for Patents  
Washington, D.C. 20231

Re: U.S. Patent Application  
Applicant: Yasushi FUJINAMI  
Our Ref.: 450100-03402

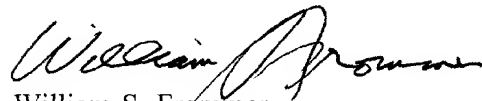
Dear Sir:

Enclosed are papers constituting the above patent application which is being filed under 37 C.F.R. 1.53 without a signed Declaration. Please accord a filing date and a serial number to such application and inform the undersigned thereof so that a signed Declaration and the surcharge required by 37 C.F.R. 1.16(e) may be duly filed.

Please address all correspondence to:

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Respectfully,



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Enclosures